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SHEET 1 OF 1

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 220040US2PCT		SERIAL NO. New US PCT application based on PCT/FR00/02468	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Claude JAUSSAUD, et al.			
				FILING DATE Herewith		GROUP 2822	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
MG	AA	5 441 911	08/15/95	Satwinder MALHI			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
MG	AO	0 587 996	03/23/94	EP		No	
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
MG	AW	C.L. SHIEH et al.: "A 1.3 μ m InGaAsP ridge waveguide laser on GaAs and silicon substrates by thin-film transfer" THIRD INTERNATIONAL CONFERENCE ON INDIUM PHOSPHIDE AND RELATED MATERIALS, CARDIFF, UK, pages 272-275 04/08/91-04/11/91					
MG	AX	Y. LU et al.: "Eutectic bonding for inducing in-plane strain in GaAs and GaAs-AlGaAs MQW thin films" ADVANCED METALLIZATION FOR DEVICES AND CIRCUITS--SCIENCE, TECHNOLOGY, AND MANUFACTURABILITY SYMPOSIUM, pages 607-612 04/04/94-04/08/94					
MG	AY	R.F. WOLFFENBUTTEL: "Low-temperature intermediate Au-Si wafer bonding; eutectic or silicide bond" SENSORS AND ACTUATORS A (PHYSICAL), vol. A62, no. 1-3, pages 680-686 07/97					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner				Date Considered			
Mara Guerrero				3-16-05			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							